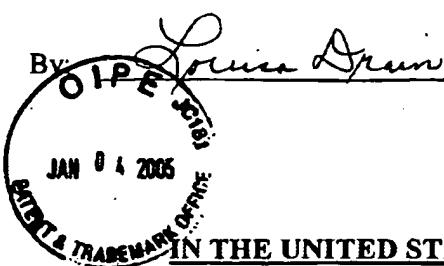


2877
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I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450, ON THE DATE INDICATED BELOW.

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| | | | |
|-------------|---|---|--|
| In re: | Patent Application of | : | Group Art Unit 2877 |
| | Takesha Nagashima <i>et al.</i> | : | |
| Conf No.: | 9575 | : | |
| Appln. No.: | 10/180,193 | : | Examiner: Layla G. Lauchman |
| Filed: | June 26, 2002 | : | |
| For: | POLARIZATION ANALYZING APPARATUS AND METHOD FOR POLARIZATION ANALYSIS | : | Attorney Docket No. 8861-442US (P28270-01) |

INFORMATION DISCLOSURE STATEMENT

The enclosed references were cited in a communication from the European Patent Office concerning counterpart European Application No. EP 02014036. It is requested that the enclosed references listed on the attached Information Disclosure Citation Form PTO/SB/08/A be placed into the application file.

Respectfully submitted,

TAKESHA NAGASHIMA ET AL.

By:

December 30, 2004
(Date)

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